



ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3102**
Satoshi TANAKA et al. : Attorney Docket No. 2005_0626A
Serial No. 10/531,006 : Group Art Unit 4111
Filed April 12, 2005 : Examiner Robert J. Grun

FOAM MOLDING METHOD AND APPARATUS:

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of July 11, 2008, Applicants hereby elect **Group I**, which is drawn to a method for foam molding under a pressurized condition of the mold and is embodied by claims 1-11, 24 and 25. Accordingly, since Group I has been elected, Applicants further elect **Species I**, which requires a special technical feature of a foamable material adhering to a surface of a core member. Claims 1-11 and 24 also read on the elected species.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Satoshi TANAKA et al.

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FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975